

PATENT NUMBER

U.S. UTILITY Patent Application

SCANNED

O.I.P.E.

PATENT DATE

QA

441

APPLICATION NO.
09/982846

CONT/PRIOR
F

CLASS
438

SUBCLASS

ART UNIT
2812

EXAMINER

515214

APPLICANTS

Atsushi Koike
Masahiro Kanai

TITLE

Method for forming a deposited film by plasma chemical vapor deposition

PTO-2040
12/99

ISSUING CLASSIFICATION

[illegible]

☐ Continued on Issue Slip Inside File Jacket

<input type="checkbox"/> TERMINAL DISCLAIMER	DRAWINGS			CLAIMS ALLOWED	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.
<input type="checkbox"/> The term of this patent subsequent to _____ (date) has been disclaimed. <input type="checkbox"/> The term of this patent shall not extend beyond the expiration date of U.S Patent. No. _____ _____ _____	_____ (Assistant Examiner) (Date) _____ (Primary Examiner) (Date) _____ (Legal Instruments Examiner) (Date)			NOTICE OF ALLOWANCE MAILED	
				ISSUE FEE Amount Due Date Paid	
<input type="checkbox"/> The terminal ____months of this patent have been disclaimed.					
WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368. Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.					

Form PTO-436A
(Rev. 8/99)

FILED WITH: ☐ DISK (CRF) ☐ FICHE ☐ CD-ROM
(Attached in pocket on right inside flap)

(FACE)